


Search Notes 	Application/Control No. 10736612	Applicant(s)/Patent Under Reexamination SUZUKAWA, HIROKI
	Examiner Schmidt, Kari L	Art Unit 2139

SEARCHED			
Class	Subclass	Date	Examiner
713	182	8/27/2007	Kari Schmidt
713	168	8/27/2007	Kari Schmidt
703	whole class	8/27/2007	Kari Schmidt
340	573.1	8/27/2007	Kari Schmidt

SEARCH NOTES		
Search Notes	Date	Examiner
Inventor Search (eDAN and PALM)	8/27/2007	Kari Schmidt
340/573.1 keyword search: "proximity and RFID" and "proximity and RFID and security"	8/27/2007	Kari Schmidt
Google Search: badge and proximity and RFID	8/27/2007	Kari Schmidt
Google Search: proximity access control and IBM and security	8/27/2007	Kari Schmidt
Google Search: reticle of wafer	8/27/2007	Kari Schmidt

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner